

250507US-2 DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF : :

YOSHIKI IGARASHI, ET AL. : GROUP UNIT:

SERIAL NO: NEW DIV. APPLN. : :

FILED: HEREWITH : EXAMINER:

FOR: OXIDE FILM ETCHING METHOD : :

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to initial examination on the merits, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper

Listing of the Claims begins on page 3 of this paper.

Remarks begin on page 9 of this paper.